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U.S. **UTILITY** Patent Application

O.I.P.E.

PATENT DATE

APPLICATION NO.		CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER	
	09/942213	F	- 438 -7 82-	145	-2012	U 5	itrage
ANTS	Maki Tana Masahiro				2625	:	J

Maki Tanaka Masahiro Watanabe Kenji Watanabe Mari Nozoe

Method and apparatus for inspecting a semiconductor device

TITLE

PTO-2040 12/99

ISSUING CLASSIFICATION									
ORIGINA	L	CROSS REFERENCE(S)							
CLASS	SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)						
INTERNATIONAL	CLASSIFICATION		· □ Continued on Issue Slip Inside File Jacket						

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		DRAWINGS		CLAIMS ALLOWED		
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The term of this patent				NOTICE OF ALLOWANCE MAILED		
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not extend beyond the expiration date of U.S Patent. No.				ISSUE FEE		
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